

Notice of References Cited	Application/Control No. 10/066,660	Applicant(s)/Patent Under Reexamination SEKIGUCHI ET AL.	
	Examiner Neveen Abel-Jalil	Art Unit 2165	Page 1 of 1

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*	B	US-6,792,463	09-2004	Lamberton et al.	709/227
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NON-PATENT DOCUMENTS

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